



520.39649CX3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: MASUDA et al
Serial No.: 10/810,598
Filed: March 29, 2004
For: Plasma Processing System And A Sample Processing Method
Art Unit: 1763
Examiner: P. Hassanzadeh

AMENDMENT

Mail Stop: Amendment (Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 24, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated September 24, 2004. The amendments are listed below and set forth on the following pages.

Amendments to the Specification:

Amendments to the Claims;

Amendments to the Drawings describing changes to drawing shown in the Appendix;

Remarks are included following the amendments; and

An Appendix including amended drawing figures is attached following the Remarks.

01/27/2005 DENMANU1 00000002 10810598

03 FC:1201 200.00 OP
04 FC:1202 150.00 OP